

Notice of References Cited		Application/Control No. 10/695,396	Applicant(s)/Patent Under Reexamination KIM ET AL.	
		Examiner DAVID Y. CHUNG	Art Unit 2871	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,285,301	02-1994	Shirahashi et al.	349/143
*	B	US-6,005,542	12-1999	Yoon, Sang Young	345/92
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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